



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Shinichi Eda *et al.*

U.S. Serial No: 09/827,846

Filed: April 6, 2001

For: MICROPARTICLE ENHANCED LIGHT SCATTERING AGGLUTINATION ASSAY

Examiner: Gailene R. Gabel

Group Art Unit: 1641

Docket No.: 100554-34635

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Amendment under 37 C.F.R. § 1.111

In response to the Office Action mailed April 7, 2003, please amend the above-identified patent application as follows:

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